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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/716,424 Confirmation No. 6953
Applicant(s) : Il-Young KWON
Filed : November 20, 2003
Art Unit : 2823
Examiner : Garcia, Joannie A.
Entitled : METHOD FOR MANUFACTURING CAPACITOR BOTTOM
ELECTRODE OF SEMICONDUCTOR DEVICE

Attorney Refer. : 123037-05005115
Customer No. : 43569

LETTER TO THE OFFICIAL DRAFTSPERSON

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 27, 2005


Sir:

X The informalities noted in Examiner's Amendment/Comment or in the Office action of Paper No./Mail Date 03-14-05 have been:

X Corrected on substitute sheets of Formal Drawings. (15 sheets, Figs. 1A-4G)

Respectfully submitted,

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